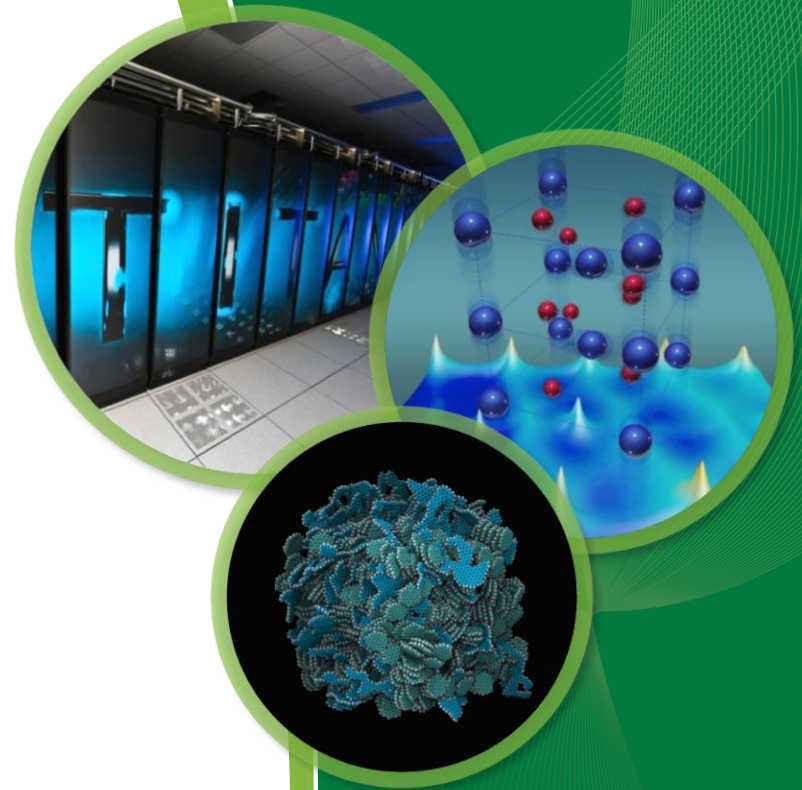


Plasma Processing at ORNL

Marc Doleans
ORNL/SNS



Overview

- In-situ plasma processing at SNS
 - Deployment to high-beta cryomodules led to 1 GeV beam energy!
 - Future deployment to medium beta CM for Proton Power Upgrade (PPU)
- Plasma processing R&D for LCLS-II cryomodules
 - R&D collaboration between SLAC, FNAL and ORNL

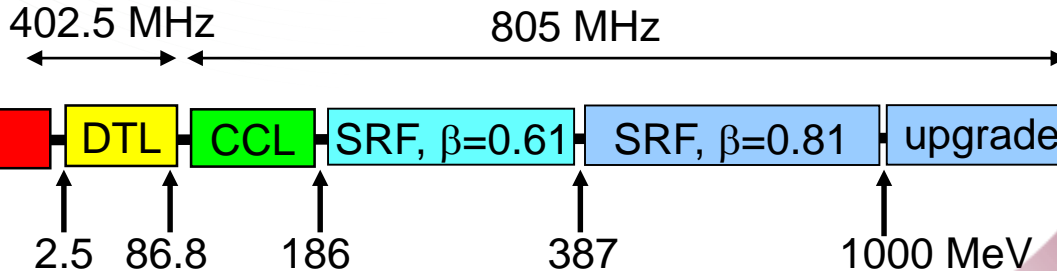
SNS Machine Layout

Front-End:

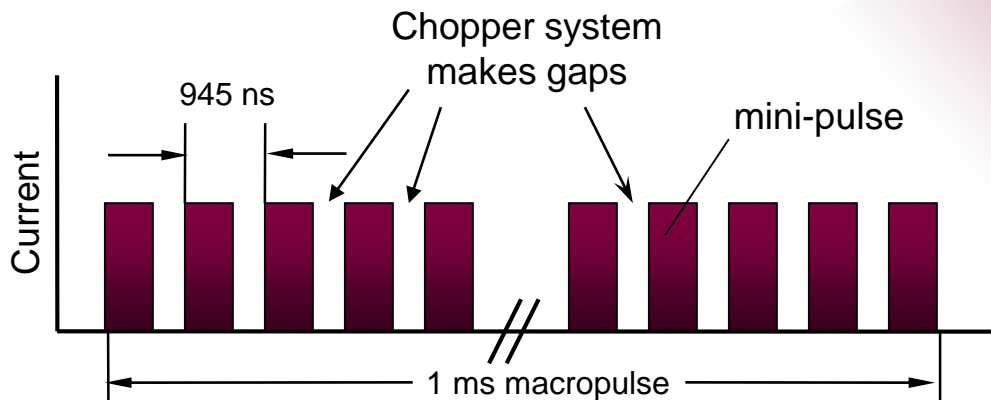
1 msec long chopped H-beam at 60 Hz

LINAC:

Accelerates beam to 1 GeV
SRF linac 23 cryomodules

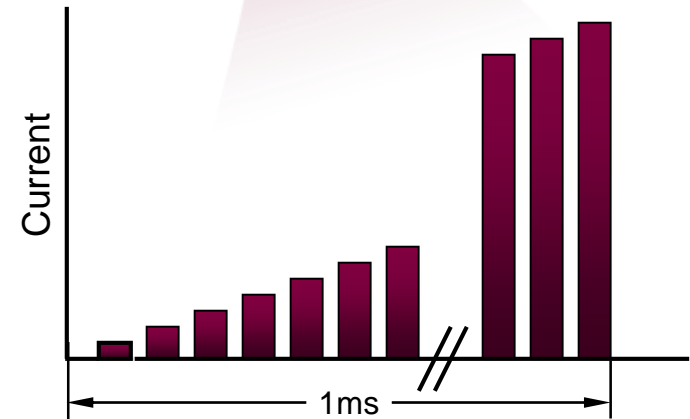
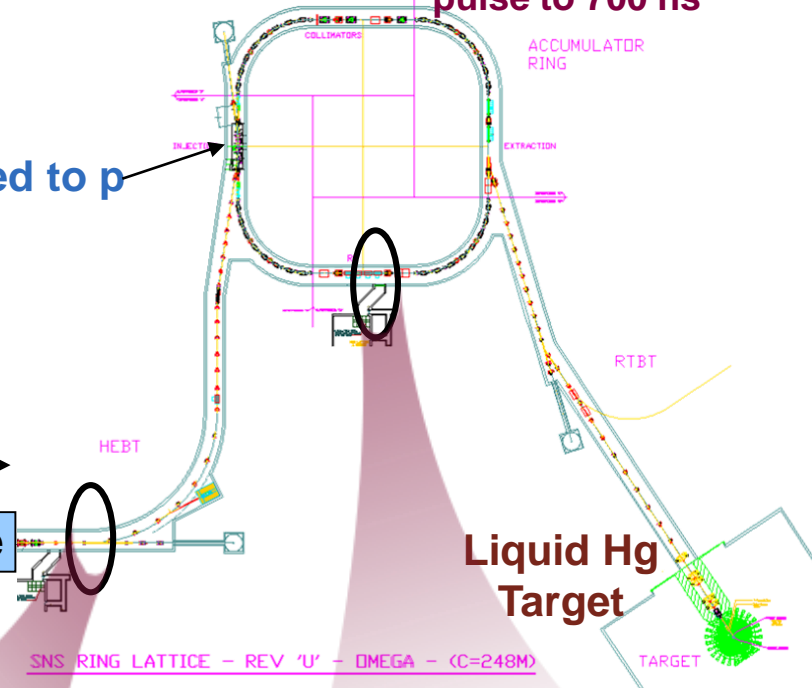


H- stripped to p



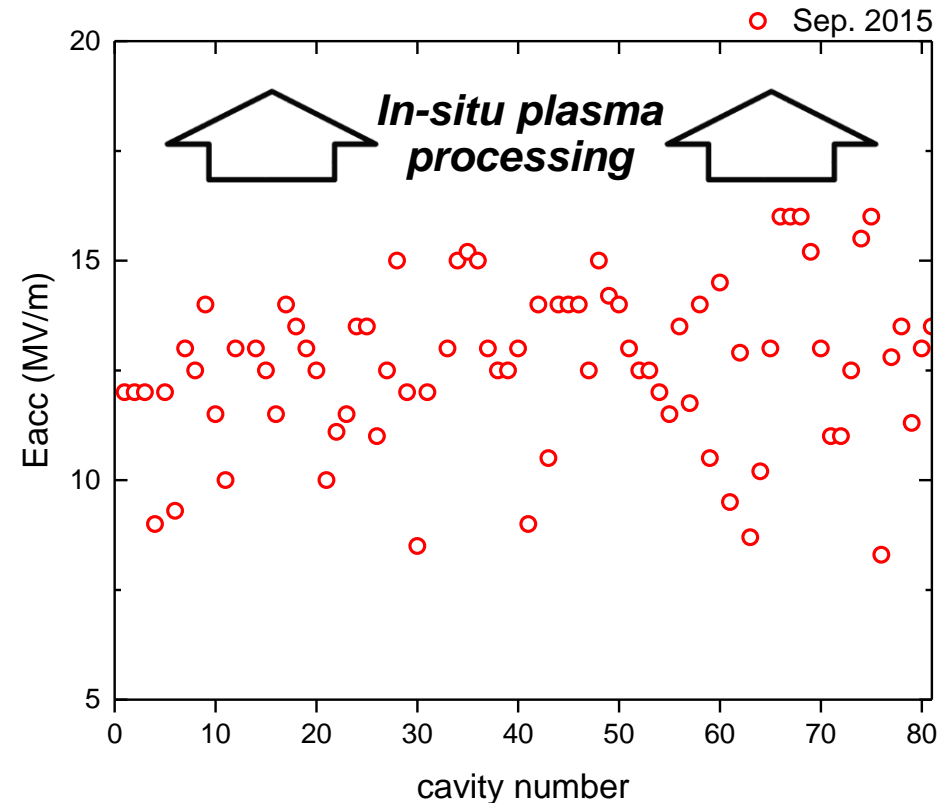
Average macropulse beam current: 26 mA

Accumulator Ring:
Compress 1 msec long pulse to 700 ns



In-situ plasma processing to increase SNS linac energy

- **Higher linac energy provides more margin for reliable operation at 1.4 MW**
 - Aim 1 GeV beam energy at 60 Hz
- **Most cavities at SNS are limited by field emission (FE) leading to thermal instability in end-groups**
 - Average accelerating gradients are 12 and 13 MV/m for the two cavity geometries
- **Developed in-situ plasma processing to reduce FE and increase accelerating gradients***



M. Doleans et al., NIMA **812** (2016) pp50-59

SNS operating at 1 GeV !

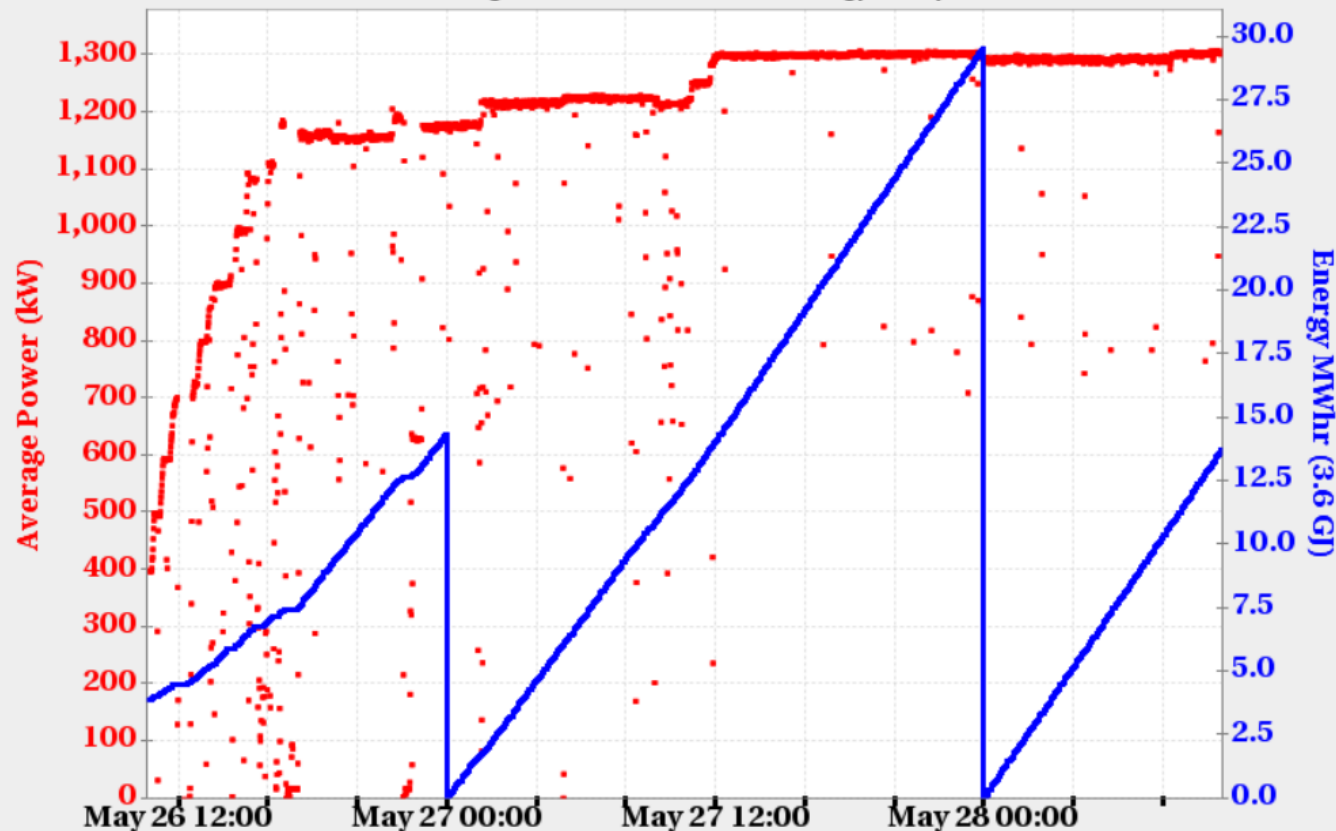


Status

[Overview](#)[Beam](#)[Diagnostics](#)[Logbook](#)[Shift](#)[Experiments](#)[Availability](#)[Operators](#)[Mobile](#)[Other](#)

Power and Energy on Target

Machine Mode: Target, Max Power: 1312 kW, Energy Today: 13.7 MWhr



SNS Beam Info

As of 10:05:45 on May 28, 2018

To: Target, MPS1 mSec

Manual Beam Switch Turned On

MPS Allows Beam

Continuous Shot Mode

Power on Target: 1309 kW

Charge to Target: 21.54 nC

Proton Energy: 1010.2 MeV

Ring Frequency: 1.059 MHz

Beam Rate: 60 Hz

Beam On Turns: 778

Chopper Pulse Width On: 43

In-situ plasma processing to reduce FE

- **Plasma processing aims at**
 - Reducing FE by increasing work function of cavity RF surface
 - Enabling operation at higher accelerating gradients
- **Scaling from Fowler-Nordheim equation**

$$J = a \frac{(\beta E)^2}{\phi} e^{-b \frac{\phi^{3/2}}{\beta E} + \frac{c}{\phi^{1/2}}}$$

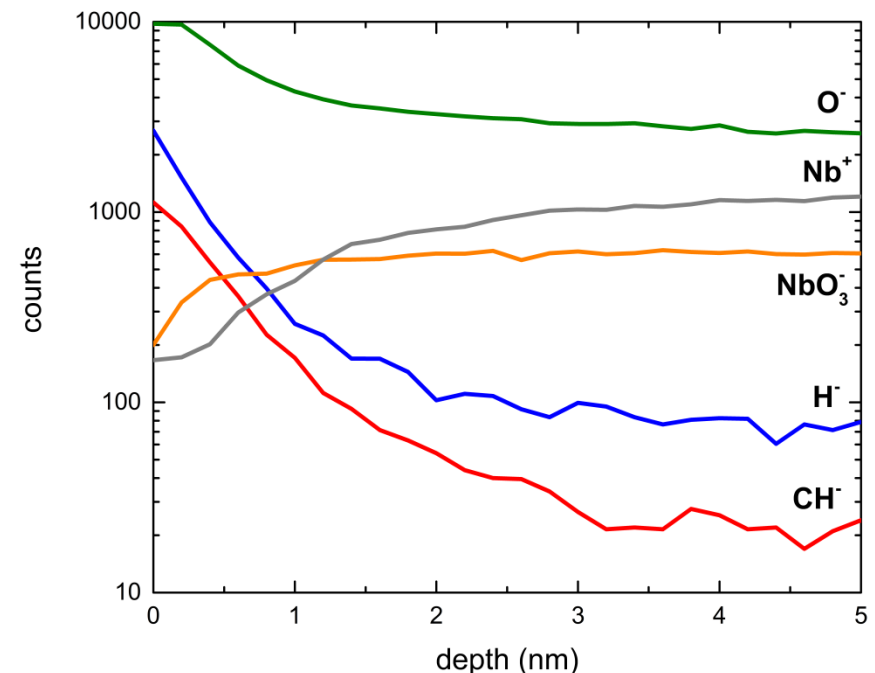
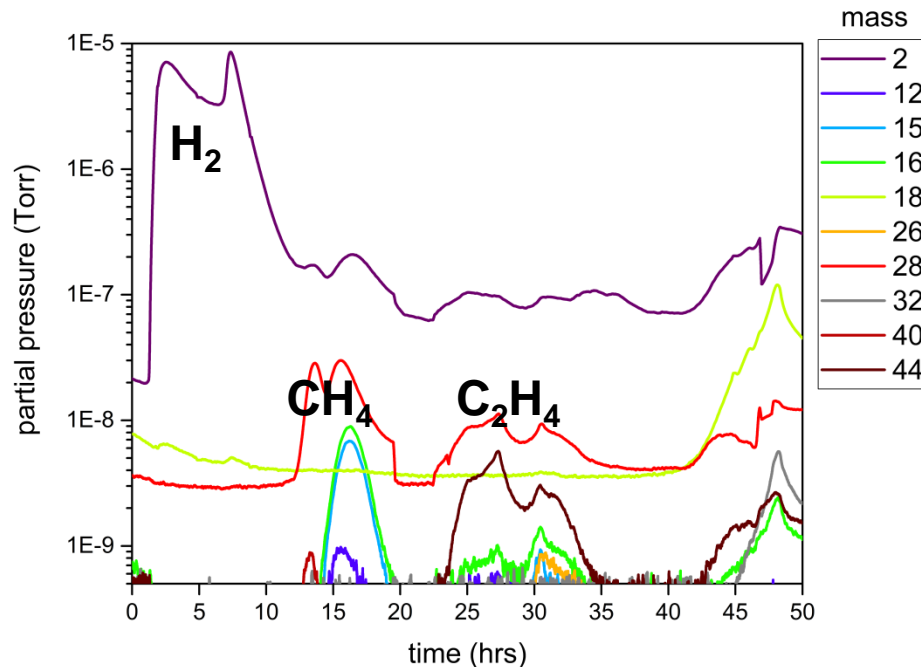
$$dJ = 0 \Rightarrow \frac{dE_{acc}}{E_{acc}} \approx \frac{3}{2} \frac{d\phi}{\phi}$$

J : current density
E : surface electric field
 β : field enhancement factor
 ϕ : work function

- 10-20% increase in ϕ leads to 20-30% increase in E_{acc}

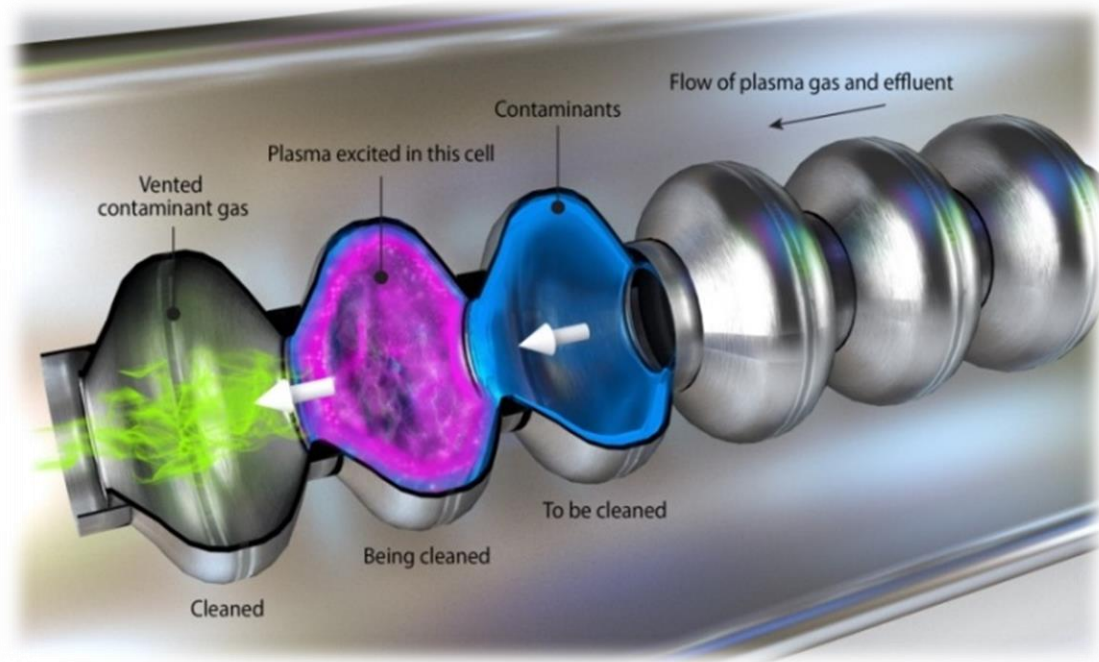
Hydrocarbon contaminants on Nb surfaces

- **Hydrocarbon contaminants observed on all Nb surfaces**
 - Volatile hydrocarbons released from cryomodule surfaces during thermal cycle
 - Hydrocarbons on offline spare cavity surfaces
 - Hydrocarbons fragments seen in secondary ion mass spectrometry (SIMS)
 - Mechanically polished niobium samples
 - Chemically polished niobium samples (BCP)
- **Hydrocarbons tends to lower work function of Nb surface**
 - Develop in-situ plasma processing to remove hydrocarbons from cavity RF surface



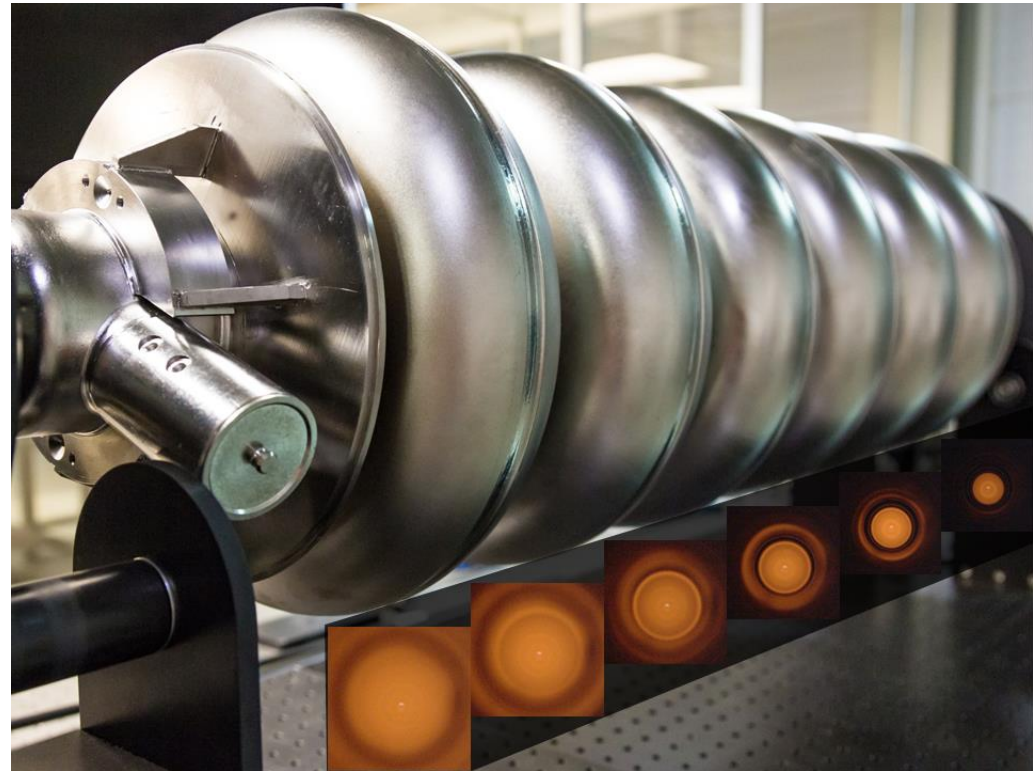
Oxygen plasma for removing hydrocarbons at SNS

- **Plasma is a rich and reactive environment**
 - Ions, e-, neutrals, excited neutrals, molecules, radicals, UV...
- **Plasma processing is a versatile technique used for various purposes**
 - Cleaning, activation, deposition, crosslinking, etching....
- **Chosen to develop a technique using reactive oxygen plasma at room-temperature**
 - Volatile by-products are formed through oxidation of hydrocarbons and pumped out



Plasma control

- Plasma excited in each of the six cells sequentially
- Fundamental passband modes excited through the power coupler
 - Dual-tone ignition technique to ignite each cell*
- Position of plasma in cryomodule determined using field probe*



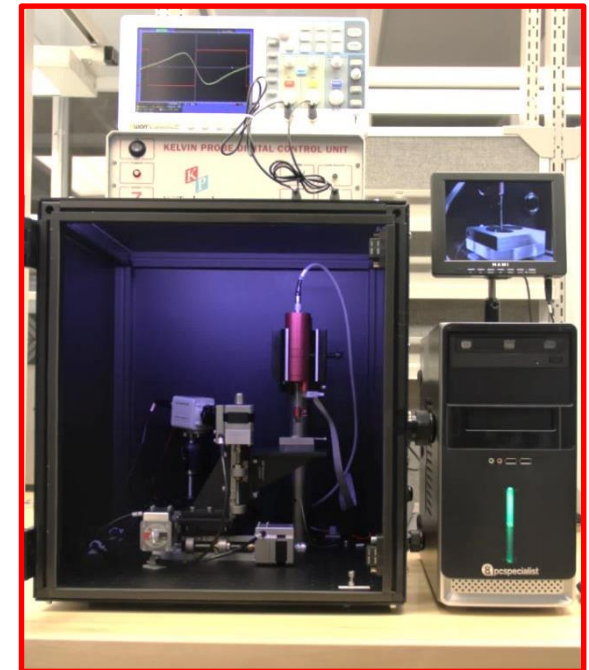
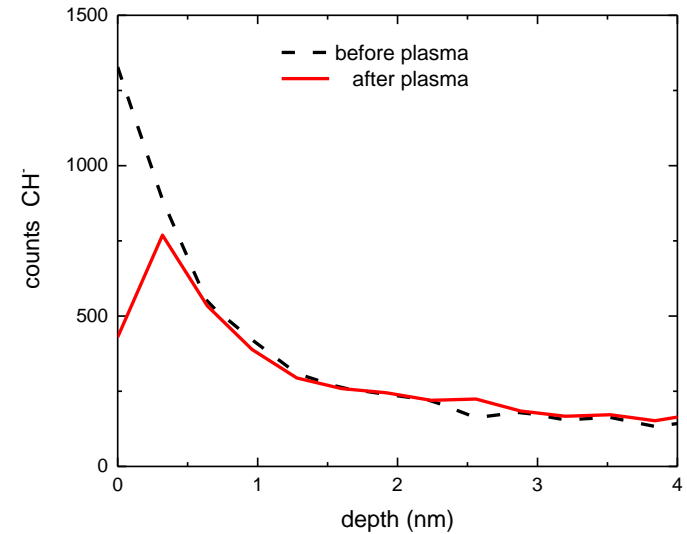
Dual-tone ignition parameters for high-beta cavities

Cell ignition	RF gen. 1	δf_1 (hbw)	p_{RF1} (dB)	RF gen. 2	δf_2 (hbw)	p_{RF2} (dB)	Γ_1	Γ_2	Γ_3	Γ_4	Γ_5	Γ_6
1	mode 5	-1.0	-4.57	mode 6	+0.50	-3.46	1.00	0.72	0.41	0.37	0.62	0.90
2	mode 2	0.0	-2.02	mode 5	-2.50	0.87	0.74	1.00	0.24	0.18	0.88	0.69
3	mode 1	0.0	-1.80	mode 3	-1.50	4.15	0.88	0.80	1.00	0.91	0.89	0.78
4	mode 1	0.0	0.63	mode 4	-2.25	2.79	0.77	0.16	0.92	1.00	0.16	0.69
5	mode 2	0.0	-1.13	mode 6	-2.50	0.99	0.27	0.88	0.36	0.40	1.00	0.44
6	mode 5	0.0	-8.26	mode 6	-1.25	0.32	0.80	0.62	0.44	0.49	0.75	1.00

* M. Doleans J. Appl. Phys., **120**, 243301 (2016)

Plasma processing increases the work function of the Nb surface

- **SIMS measurement shows that the hydrocarbons are removed from the Nb top surface**
- **Scanning Kelvin Probe shows that the work function increases***
 - Nb samples $\phi=4.7$ eV initially
 - Neon-oxygen plasma processing systematically improves the work function
 - ~0.8 eV increase measured
 - Work function tends to degrade after venting to air



*P.V. Tyagi et al., Applied Surface Science **369** (2016) 29–35

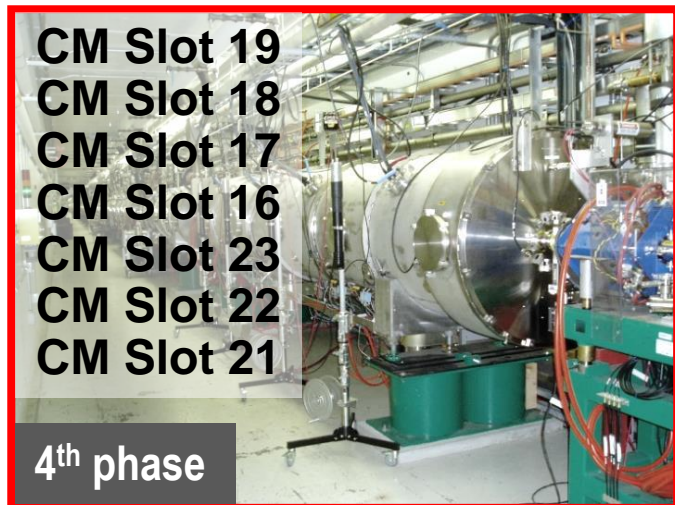
Plasma processing at SNS to reach 1 GeV



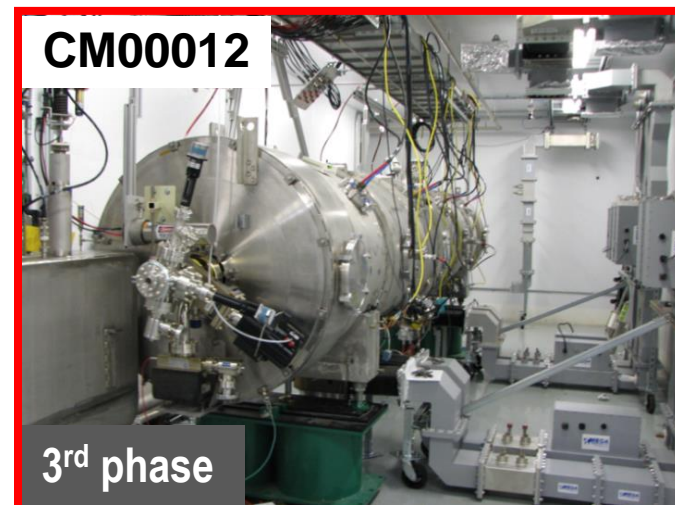
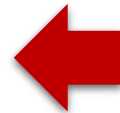
R&D with Nb samples and offline cavities



Processing of 6-cell cavity in HTA*



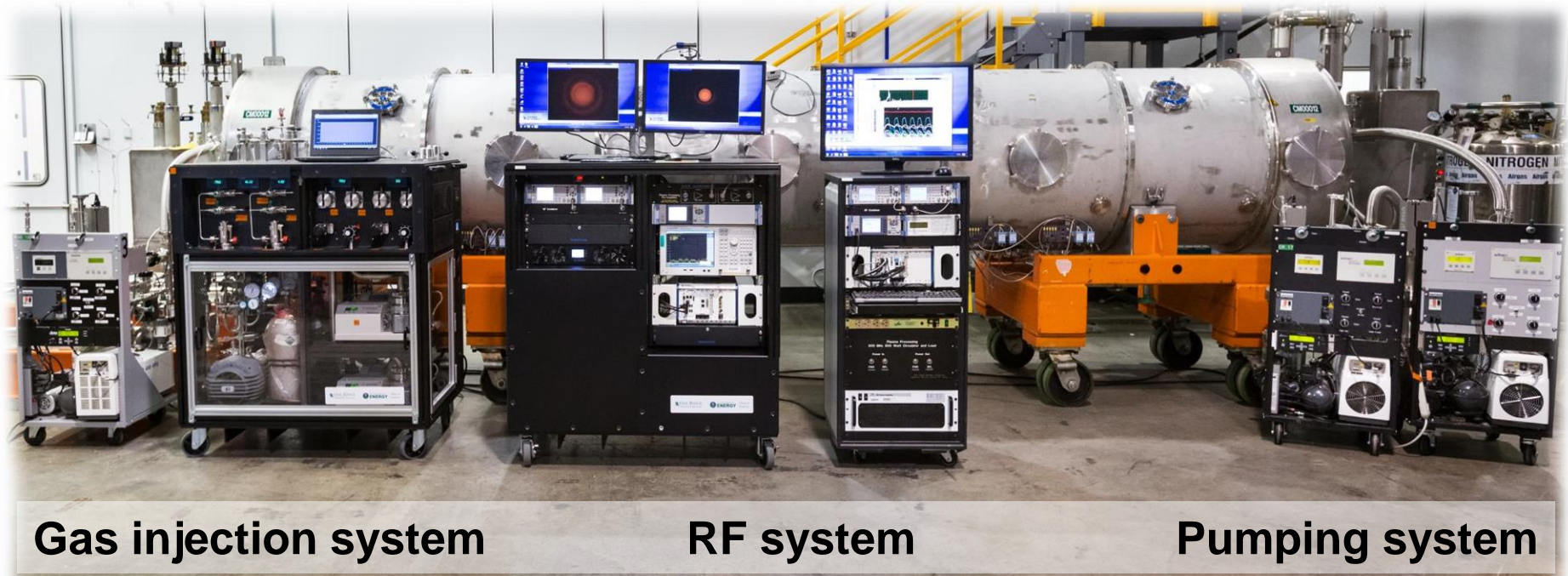
In-situ processing in linac tunnel



Processing of cryomodule in test cave

Plasma processing of an offline cryomodule

- **Plasma processing hardware**
 - Process gas cart
 - RF carts
 - Pumping carts
- **2 RF carts are used to process 2 cavities simultaneously**



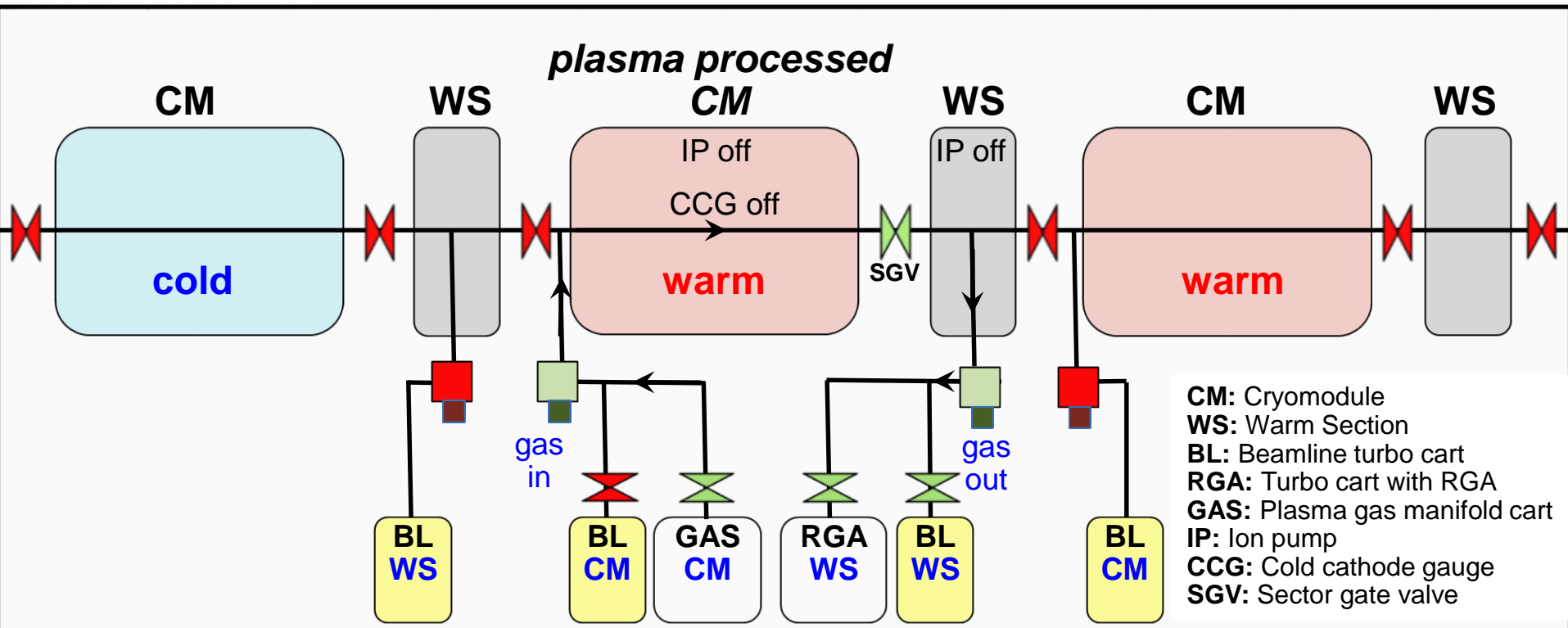
Gas injection system

RF system

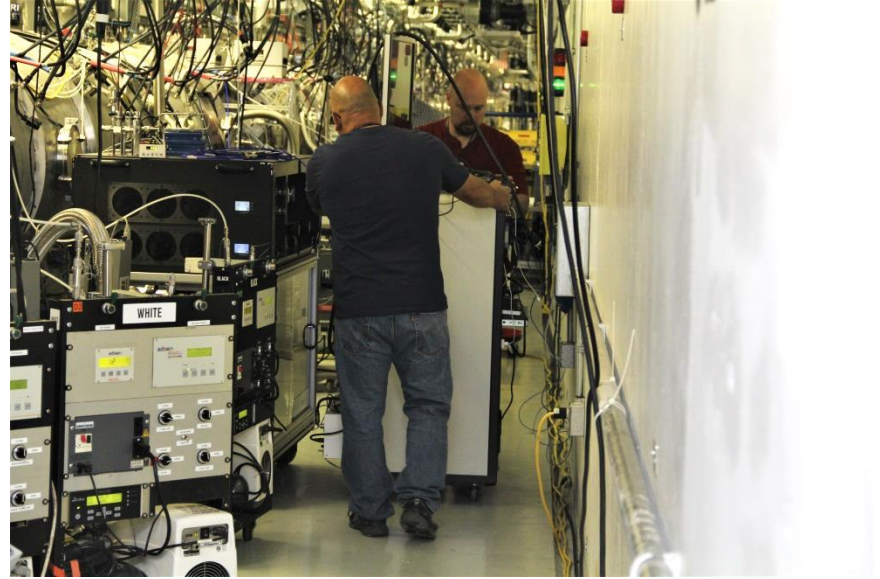
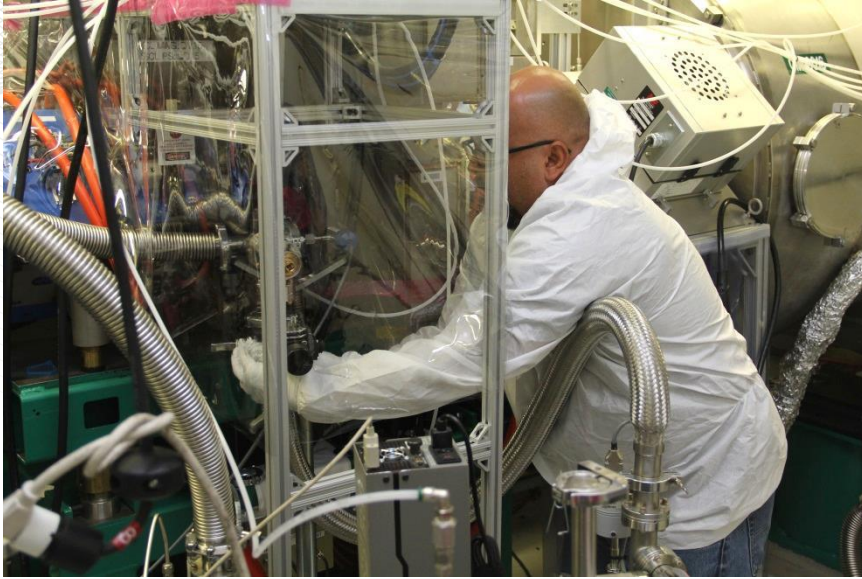
Pumping system

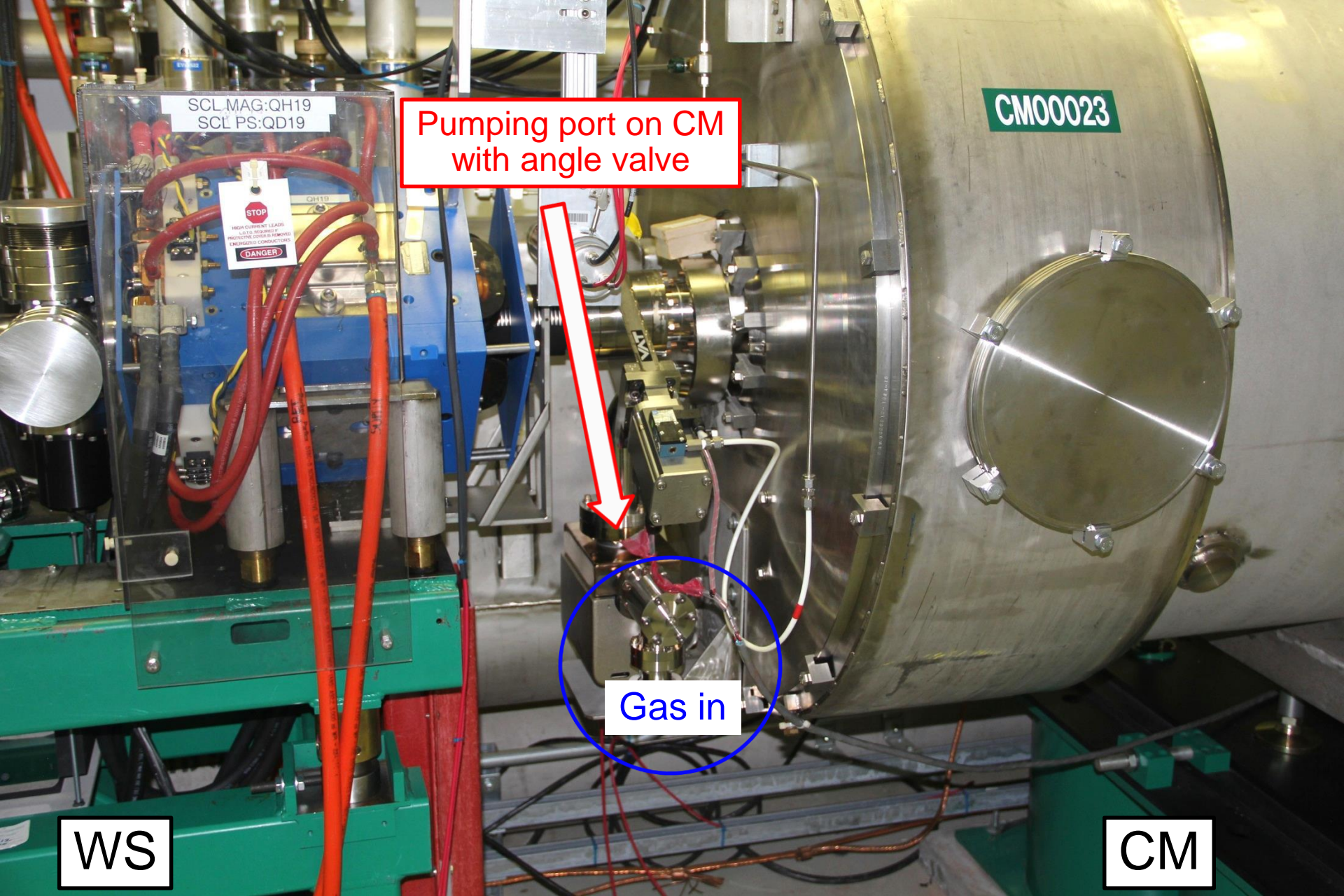
Plasma processing of a CM in SNS linac

- Warm-up 2 cryomodules
- Sections seeing process gas
 - Ion pumps and CCGs off
- At least 2 sector gate valves between process gas and cold surface
 - Mitigates risk of gas condensation on cold surfaces



Installation of plasma processing hardware





SCL MAG:QH19
SCL PS:QD19

Pumping port on CM
with angle valve

CM00023

STOP
HIGH CURRENT LEADS
LIQUID NEUTRON BEAMS
PROTECTIVE CURRENT BARRIERS
EMERGENCY CONDUCTORS
DANGER

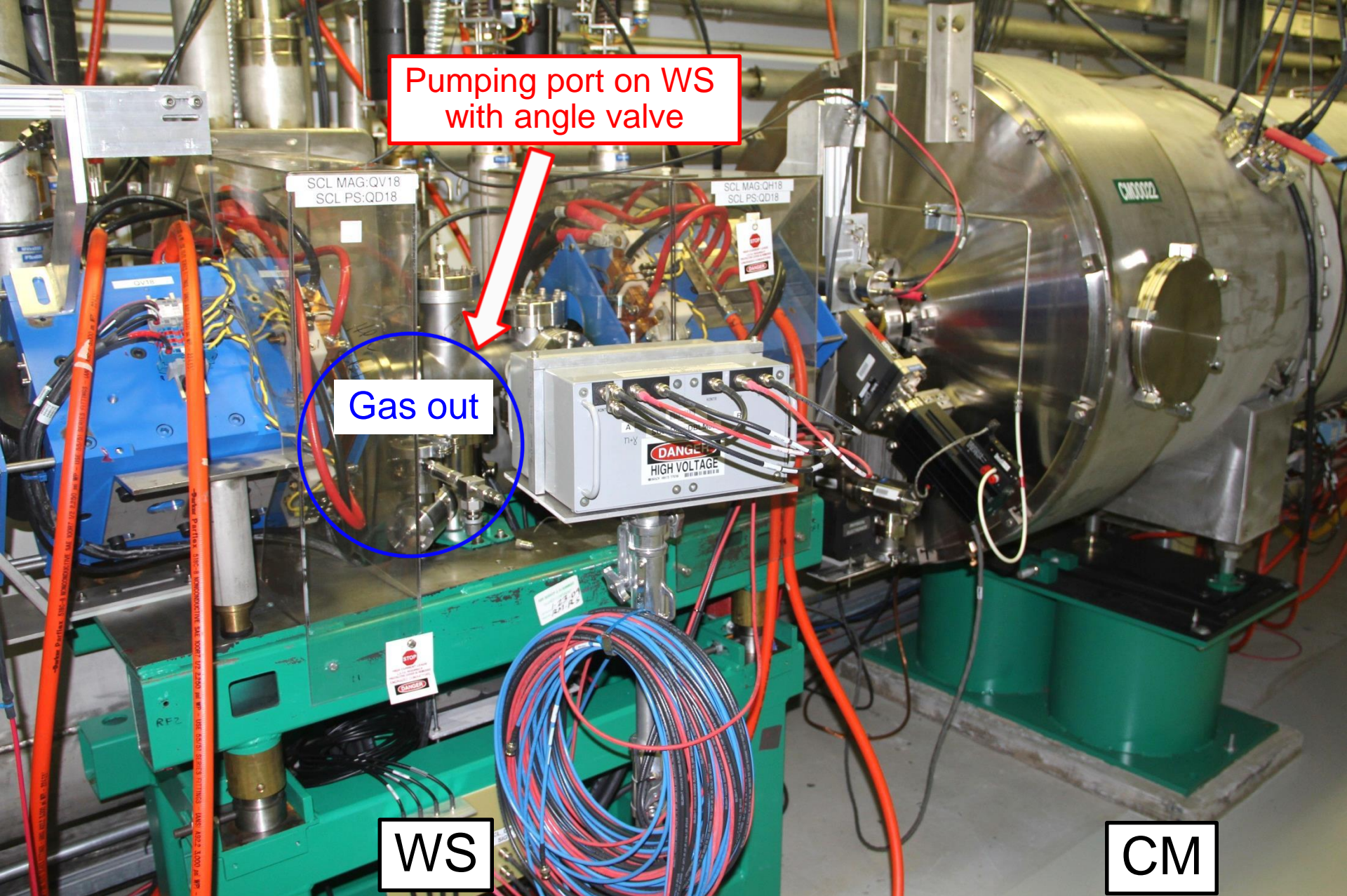
Gas in

WS

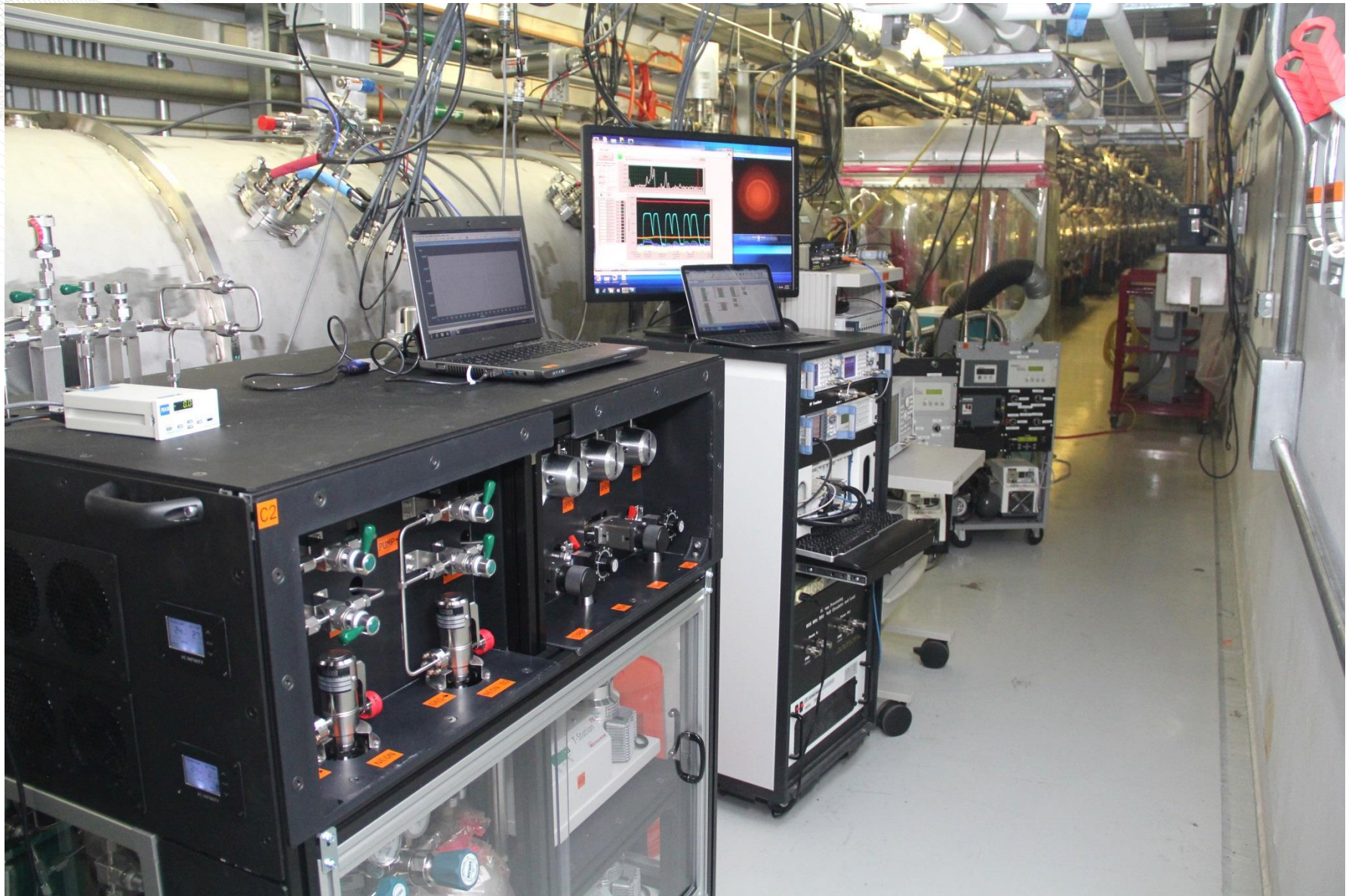
CM



Beam



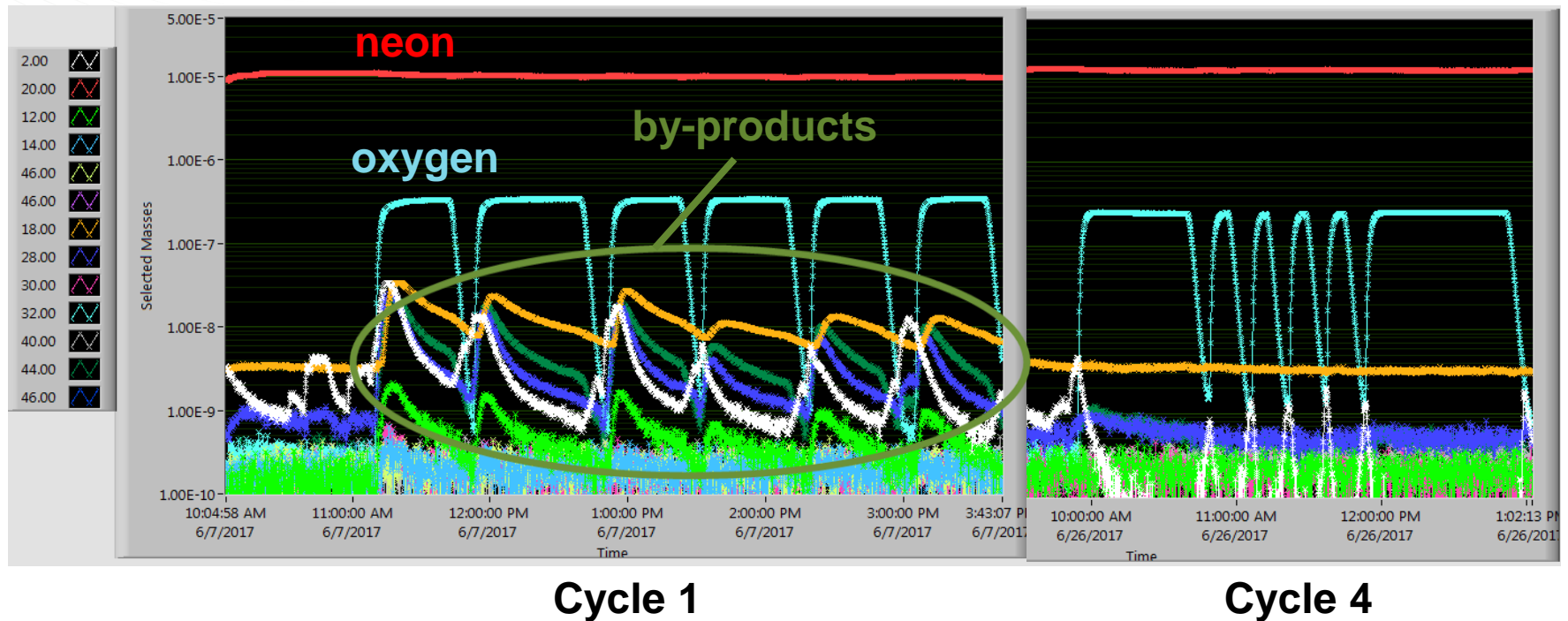
Plasma processing hardware in SNS tunnel



Applied ALARA: Radiation survey indicated best location for minimum radiation exposure during work (<1 mrem/hr)

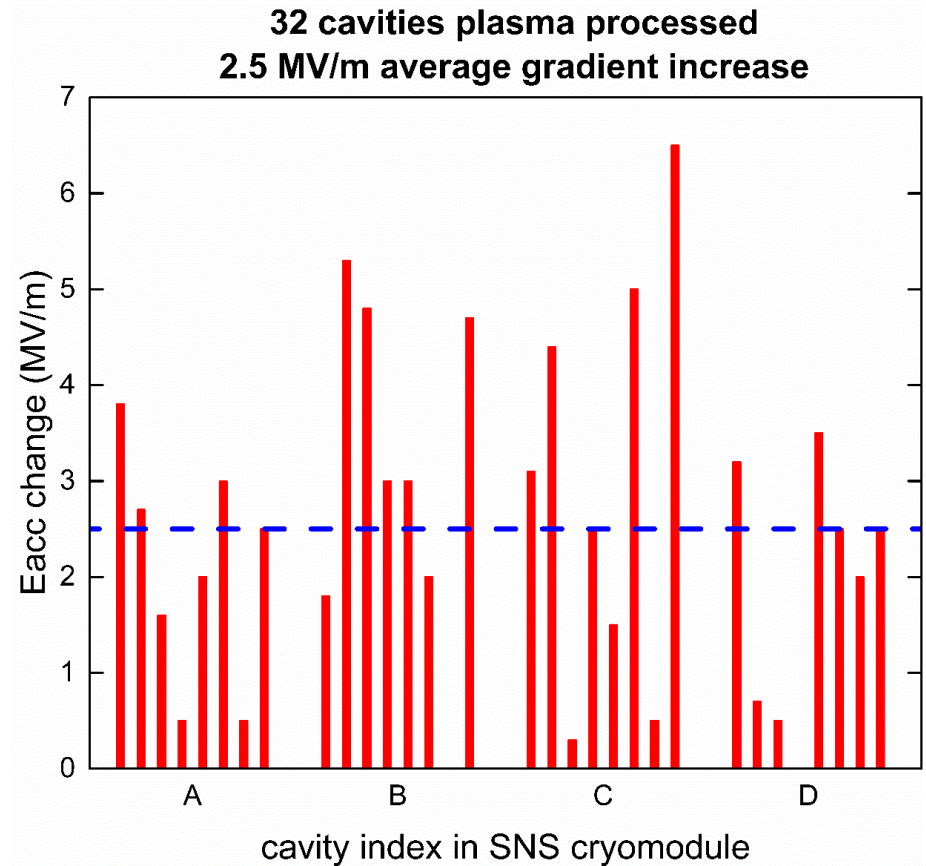
Example of gas analysis during plasma processing of a CM at SNS

- **Residual gas analysis during cleaning of the cavities**
 - Reduction of by-products as the surface is depleted of hydrocarbons through multiple cleaning cycles

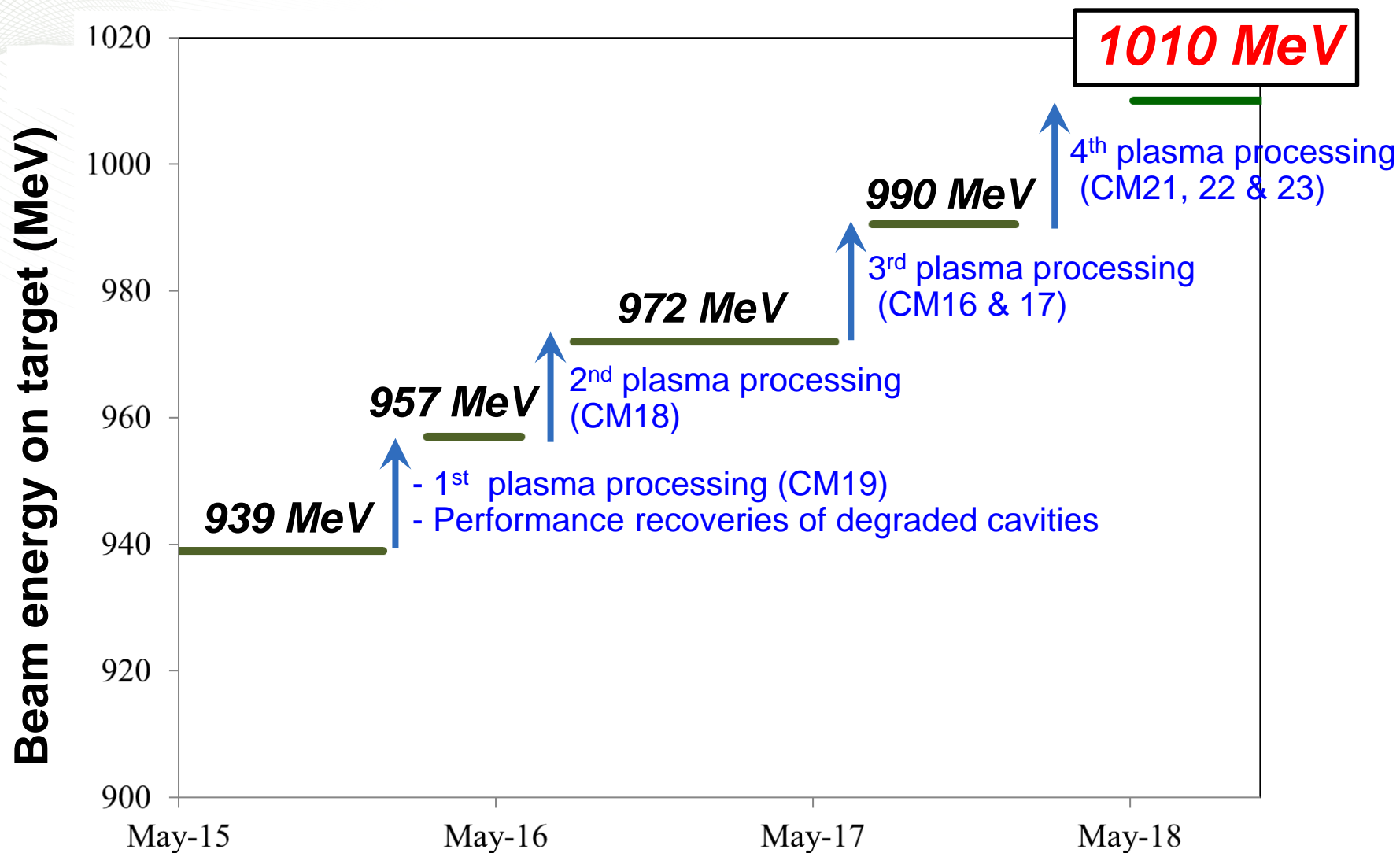


Plasma processing deployment at SNS

- 8 high beta cryomodules have been successfully plasma processed
 - 7 cryomodules in the tunnel
 - 1 cryomodule offline
 - Accelerating gradient increased by 20% on average
 - Improvement of E_{acc} ranges from 0.2 to 6.5 MV/m
 - 10 MV/m gain per cryomodule on average
 - No performance degradation from plasma processing observed so far



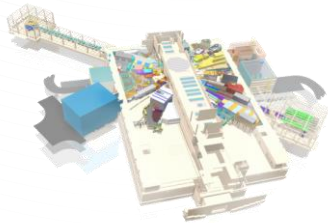
In-situ plasma processing boosts SNS to 1 GeV



Beyond 1 GeV and 1.4 MW at SNS

(courtesy J. Galambos)

24 instrument positions
19 instruments built



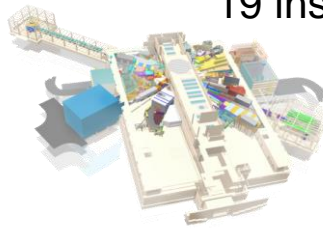
FTS

1.4 MW

Accelerator

Now

24 instrument positions
19 instruments built



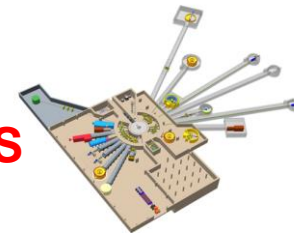
FTS

2 MW

Accelerator

After PPU Upgrade

22 instrument slots,
8 initial instruments



STS

After STS Upgrade

- Upgrade to 1.3 GeV and 38 mA beam loading (2.8 MW) – **PPU**
- Second Target Station - **STS**

PPU SCL Scope

- **Road to 1.3 GeV**

- **7 additional cryomodules will be installed in empty slots**

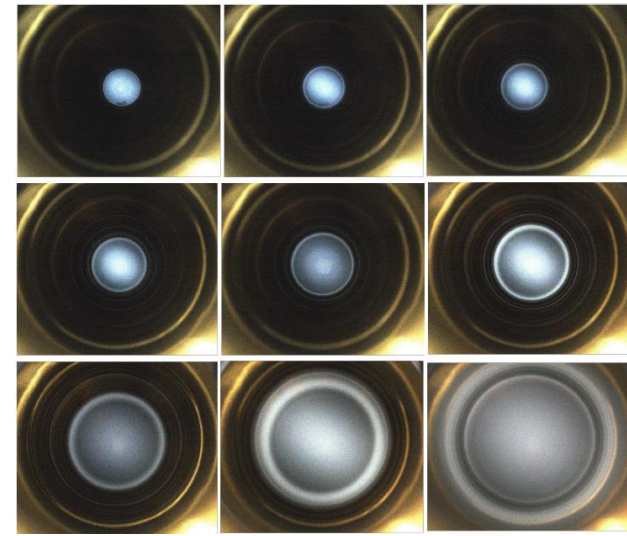
- Design E_{acc} for new PPU cavities is 16 MV/m

- **Improvement of existing cryomodules**

- Use future spare medium beta CM to replace low performing cryomodule
 - Plasma processing for medium beta cryomodules
 - Leverage available RF power in medium beta cryomodules
 - Increase medium-beta cavities E_{acc} by 1.7 MV/m on average
 - Will modify plasma processing recipe developed for high-beta cavities
 - Existing hardware will be used (same frequency 805 MHz)
 - Develop dual tone ignition parameters

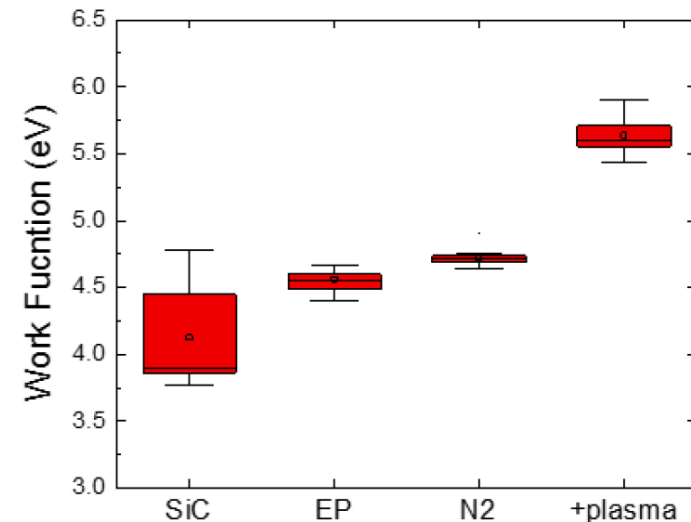
Plasma processing for LCLS-II

- On-going collaboration between three Laboratories funded by BES



(courtesy P. Berrutti, FNAL)

- Plasma processing for 9-cell 1.3 GHz LCLS-II cavities
 - Plasma ignition methodology modified to use HOM couplers *
 - Plasma processing increases work function for LCLS-II niobium surface **



* P. Berrutti et al., "Update on plasma processing R&D for LCLS-II", IPAC18

** K. Tippey et al., "Improving the work function of nitrogen doped surfaces...", IPAC18

CONCLUSION

- **In-situ plasma processing deployed successfully at SNS**
 - 1 GeV beam energy reached!
- **Plasma processing for PPU Project**
 - Plasma processing for medium beta cryomodules
- **Plasma processing for LCLS-II**
 - SLAC, FNAL and ORNL collaboration
 - Progressing very well
 - Plasma processing of an LCLS-II cavity in the near future at FNAL!